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CONFIRMATION NO. 1829

10/553,677 10/17/2005 438 1765 125685 RULE APPLICANTS Shuichi Okawa, Tokyo, JAPAN; Kazuhiro Hattori, Tokyo, JAPAN; This application is a 371 of PCT/JP04/08232 06/11/2004 *** FOREIGN APPLICATIONS ************************************	SERIAL NUMBER FILING OF		r 371(c) CLASS		GROUP ART UNIT		ATTORNEY DOCKET				
APPLICANTS Shuichi Okawa, Tokyo, JAPAN; Kazuhiro Hattori, Tokyo, JAPAN; This application is a 371 of PCT/JP04/08232 06/11/2004 ** FOREIGN APPLICATIONS ************************************	10/553,67				438		1765		NO. 125685		
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JAPAN 2003-188468 06/30/2003 *** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 04/20/2006 Foreign Priority claimed											
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35 USC 119(a-d) conditions met											
Acknowledged DAHIMENE/ Examiner's Signature Initials JAPAN / 20 1 ADDRESS OLIFF & BERRIDGE, PLC P.O. BOX 19928 ALEXANDRIA, VA 22320 UNITED STATES TITLE Mask material for reactive ion etching, mask, and dry etching method FILING FEE RECEIVED 900 All Fees All Fees 1.16 Fees (Filing) 1.17 Fees (Processing Ext. of time) 1.18 Fees (Issue) Other Other				Allowance							
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